A report on the project work titled "Polysilicon based Temperature Sensor"

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1. Objective:

To design a temperature sensor and its read out electronics meeting a required temperature range of and accuracy.

2. Target Specifications:

Temperature range and accuracy: -35°C to +125°C

Inaccuracy < +/- 0.15 °C

Read out :20 bit

Clock for readout: 32 kHz

WB nominal input frequency: 250kHz

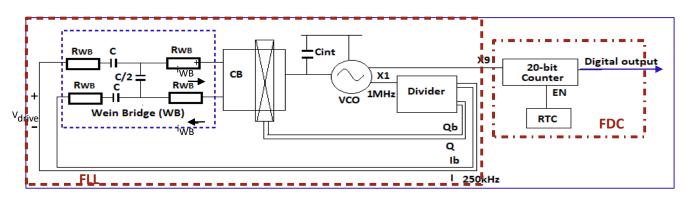
VCO nominal frequency: 1MHz

Process used: 0.13µm SKY130A process

3. System Functional Description:

Design of temperature sensor is based on the below literature:

"[1] Poungwon Park, David Ruffieux, Kofi A.A. Makinwa, "A Thermistor-Based Temperature Sensor for a Real-Time Clock With 2ppm Frequency Stability", IEEE Journal of Solid-State Circuits, Vol.50, No.7,Jul. 2015, pp 1571-1580." Functional block diagram of the system is given below:



Functionality of the individual blocks are verified. Simulation results of individual blocks are given below:

4. System functional block level simulation results

i) Wein Bridge:

Component values are chosen for a resonant frequency of 250 kHz. The value of resistance Rwb is used as $135 \text{k}\Omega$ and Capacitor Cwb is 4.7 pF. The schematic diagram of Wein Bridge is given in the below Fig.1a. Circuit component details, layout details and charaterization of Wein Bridge functionality at extreme temperatures and under process corners are described below:

(a) Circuit Details:

Polysilicon Resistor used is res_xhigh_po_0p35 whose resistance is of $2k\Omega$ /square. The capacitor used is cap_mim_m3_1, the capacitance between metal 4 and metal 3. The capacitance defined by the process is $2.2 fF/um^2$. Dimensions used are given in the table below:

Table 1a: Component values of Wein Bridge

		0		
	Value	W(um)	L	Multiplication
			(um)	Factor MF
res_xhigh_po_0p35	135k	23.625	0.35	-
cap_mim_m3_1	4.7pF	24	24.1	4

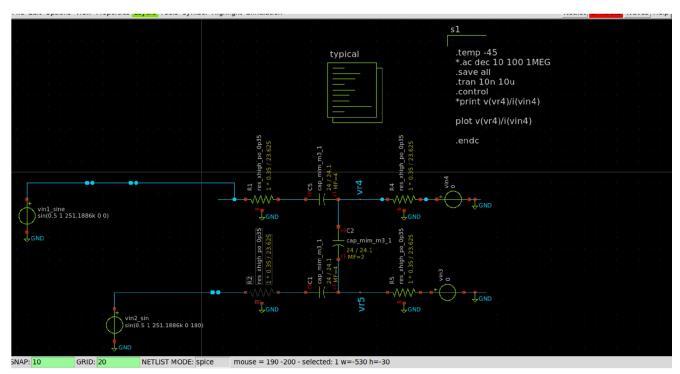


Fig. 1a. Circuit Schematic of Wein Bridge

Polysilicon Resistance value is characterized as a function of temperature and under process corners. The characteristics at nominal process is shown in Fig. 1b. With process corners , the resonant frequencies are extracted from the transfer characteristics of the bridge using an AC analysis. Plots of Resistance vs Temperature and transfer functions for two process corners are given Fig.1b,c,d and e and a summary of the resonant frequencies under various process corners are provided in the table 1b.

PROCESS PARAMETER: HH



Fig. 1b. Variation of R with Temperature

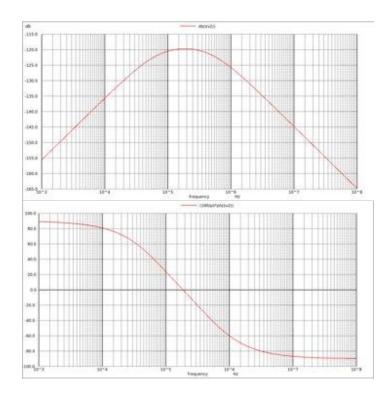


Fig. 1c. Transfer function of Wein Bridge at HH process corner at -35°C

(b)Characteristic under LL process corner:

PROCESS PARAMETER: LL



Fig. 1d. Variation of R with Temperature at LL process corner

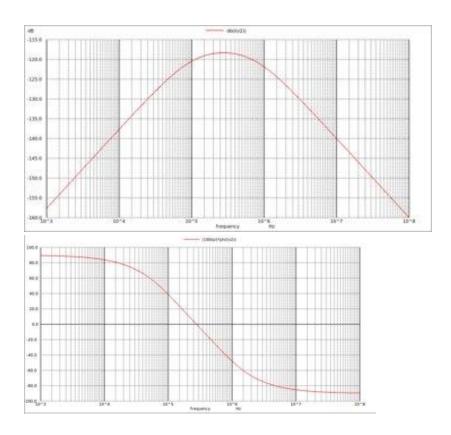


Fig. 1e.Transfer function of Wein Bridge at LL process corner at -35°C

Similar characteristics are extracted under process combinations hl and lh and at extreme temperatures. The resonant frequency of the bridge at extreme temperatures and at room temperature are shown in Table.1b.

Table 1b. Resonant frequencies across process corners and at extreme temepratures

	Resonant Frequency @		
	-35°C	27°C	125°C
tt	224.91	247.742	280.5434
11	276	304.1	344.35
hh	186.21	206.445	232.27
hl	237.137	261.216	295.8
lh	216.77	238.781	270.4

The tabulation shows a worst case deviation of 64kHz from its nominal resonant frequency.

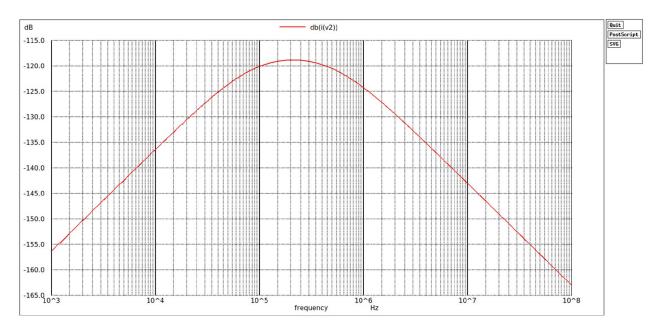
(C) Layout Details of Wein Bridge:

Details of Resistor realization and capacitance realization is given below:

Resistors are realized as a single strip of polysilicon material. 16 Dummies are used around the resistors. M1 to M2 are used for routing.

For capacitor realization a common centroid approach is used to place capacitors. 1.17pF capacitor is considered as an unit capacitor to realize 4.7pF. 16 Dummies are used around. Routing is carried out using M1 to M4 metals.

Post layout simulations of the constructed Wein bridge are given in Fig.1f below:



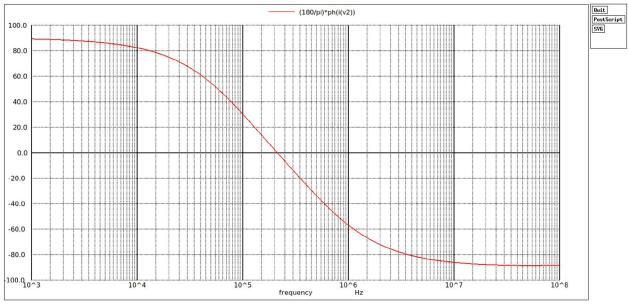


Fig.1f. Post layout Simulation of transfer function of Wein Bridge

Report showing resonant frequency of Analysis is shown in Fig. 1g.



Fig. 1f. Report showing Resonant frequency extracted from AC analysis.

Centre freuency of the Wein Bridge in post layout simulation at room temperature is found to be 114.1603kHz showing a deviation of 20.84kHz from the required resonant frequency of 135kHz.

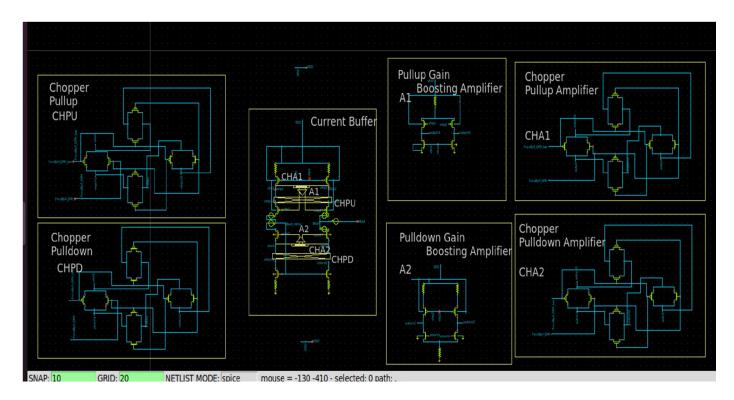
(D) Pending Task: At extreme temperatures and process corners, postlayout simulations and characterization of the bridge are yet to be carried out.

ii)Current Buffer

Functionality of current buffer used is a chopper based regulated low voltage swing cascode current buffer as realized in [1]. The circuit schematic of the current buffer integrated with chopper is shown in Fig. 2a. Chopper here plays the dual role of mixing operation and upconversion of flicker noise.

The current buffer used is of Cascode low voltage swing topology with gain boosting amplifiers to improve its input and output impedance. Four choppers are used CHA1, CHA2, CHPD and CHPU. CHA1, CHA2 plays the role of mixer and for upconversion of flicker noise from the current source, whereas while chopping action is carried out CHPU and CHPD are meant for maintaining the terminal polarity of the gain boosting amplifiers for negative feedback action.

Circuit component details, layout details and charaterization of chopper integrated Current Buffer functionality at extreme temperatures and under process corners are described below:



(a) Circuit Component Details:

Circuit is designed for the Specifications given in Table 2a and component details are Table 2b.

Table 2a. Specifications

Parameters	Values
Bias Current	3uA
Input	2.5uA
maximum	
current	
amplitude @	
resonance	
Pull Up	33dB
amplifier Gain	
Pull Down	28dB
amplifier Gain	

Device Dimesions, Resistor values and Bias voltages used in the cascode current buffer circuit, pull down amplifier, pull up amplifier and chopper circuit are shown in Fig. 2b,c,d &f . Their respective component values are given in Table 2b.

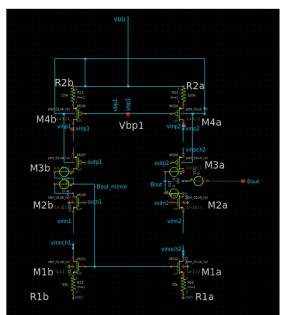


Fig. 2b. Circuit Schematic of low voltage swing cascode current Buffer

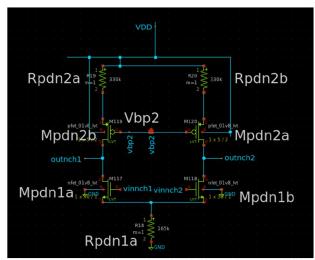


Fig. 2c. Circuit Schematic of gain boosting amplifier in pull down path

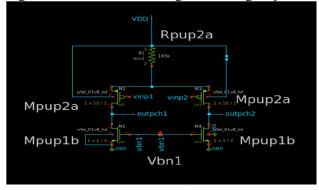


Fig. 2d. Circuit Schematic of gain boosting amplifier in pull up path

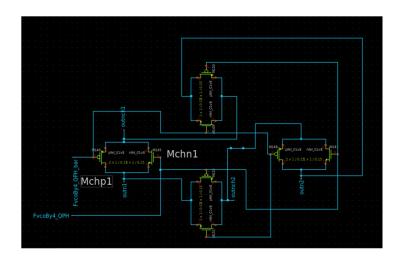


Fig. 2d. Circuit Schematic of chopper

Table 2b: Component values of Chopper based Current Buffer

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Module	Circuit	Values
	Component	
Cascode	M1a	W/L=1/2
low	M2a	W/L=12/1
voltage	M3a	W/L=10/1
swing	M4a	W/L=5/1
Current	R1a	55kohm
Buffer	R2a	110kohm
	Vbp1	0.8V
Gain	Mpdn1a	W/L=36/1
Boosting	Mpdn2a	W/L=5/2
Amplifier	Rpdn2a	330k
in Pull	Rpdn1a	165k
Down	Vbp2	1.08V
Gain	Mpup1b	W/L=1/4
Boosting	Mpup2a	W/L=10/1
Amplifier	Rpup2a	165k
in Pull Up	Vbn1	0.561V
Chopper	Mchn1	W/L=1/0.15
	Mchp1	W/L=2/0.15

(b) Layout Details

Unit resistor chosen for realization is 110kohm and all other resistor in the current buffer are derived using combinations of this unit resistor. Dimension W/L for 110kohm resistor turns out to be 19.25um/0.35um. Common centroid method is employed for placing the resistors and 22 dummies are placed around. Metals M1 to M3 are used for routing. Dummies are placed for NMOS and PMOS transistors of cascode current buffer and amplifier stages.

(c) Postlayout Simulations

Postlayout simulations are carried out with an external input sinusoidal current source of amplitude 2uA at nominal resonant frequency of 250kHz fed to common gate stage of cascode current source and quadrature phase square waveform with respect to the current source , with amplitude 1.8V , are fed to the chopper circuit. The simulations were carried out in room temperature and under process corners. The resulting ouput current waveform is shown in the Fig.2e.

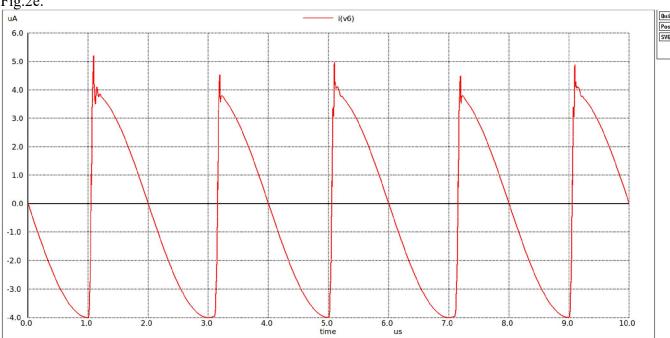


Fig.2e. Output Current from Current Buffer

From the current waveform it can be seen that output amplitude is approximately of 4uA, and hence shows buffer operation. The chopping operation is also evident from the reversal in the polarity of the ouput current waveform.

(D) Pending Task: At extreme temperatures and process corners, postlayout simulations have to be carried out.

(3) Switch Capacitor Filter:

A low pass filter is designed to extract a DC voltage proportional to phase error resulting when the bridge is excited with a frequency other than the resonance condition. A switch capcitor filter with a sampling frequency twice that of the resonant frequency is used as in [1], to minimize the effect of ripple resulting due to higher order even harmonics because of chopping operation. Inorder to realize twice the sampling rate the two parallel path switch capacitor filters operated with 180 degree phase shifted resonant frequency signal, when the first path operates in hold mode the other path will be in sampling mode and vice versa.

The circuit schematic of the time interleaved switch capcitor is shown in Fig.3a.

Component details and post layout simulations are given below:

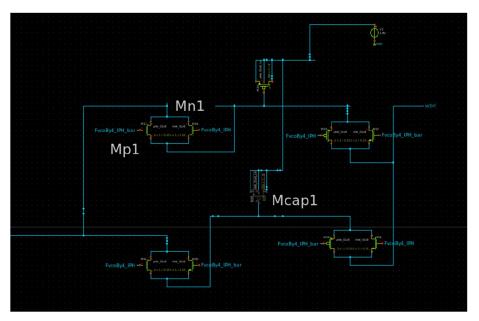


Fig. 3a. Circuit schematic diagram of Switch Capacitor Filter

(A) Component details

The filtyer is designed for a cutoss frequency of 200Hz. Capacitor value used is 80pF which realized using PMOSFET with source, drain and substrate terminals shorted together acts as one terminal and gate acts as the other terminal.

Component values are shown in the below Table.3

Table 3: Component values of Switch Capacitor Filter

	Value	W/L	Multiplication
			Factor MF
Capacitor (Mcap1)	80pF	7/8	200
Mn1	-	1/0.15	-
Mp1	-	2/0.15	-

(B) Layout details

80pF capacitance in layout is realized using 20 fingers PMOS transistor with a multiplier of 20, size of each transistor was chosen as 7/8. Local interconnect and metal 1 are used for routing.

(C) Postlayout Simulations

AC analysis was carried out using the postlayout netlist for determining the capacitance value and in this case the switch was considered to be an always on switch. AC analysis was carried out with an input ac current source and a shunt resistance of 10Mohm was used to model the output resistance of current buffer. The cut off frequency was observed to be 184 Hz and the capacitor was found to be 84pF. Cutoff frequency was observed to match with prelayout simulations. The bode plot obtained from pre and post layout simulations are shown in 3b. From the figure it can be seen that prelayout simulation characteristics matches with that of postlaout simulations.

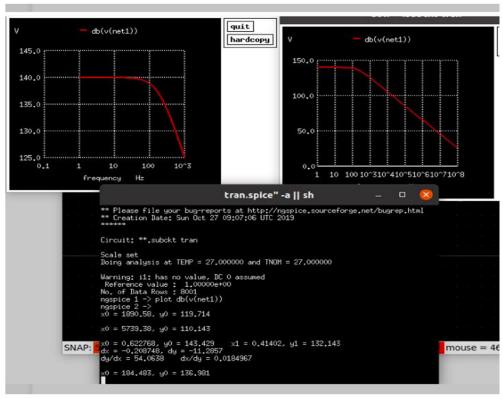


Fig. 3b. Pre and post layout simulations of lowpass filter

(D) *Pending Task:* At extreme temperatures and process corners, postlayout simulations have to be carried out.

(4)VCO is realized is a nine stage current starved ring oscillator similar to that in [1] except that the current source is presently being used without a source degeneration resistor. The circuit schematic of VCO is shown in Fig. 3a. The current source used in the ring oscillator is a control voltage dependent current source with the maximum current capability of 12uA. The transistors of

the delay stages are sized such that the range of frequency obtained is +/- 200kHz from 1MHz which is based on Wein Bridge resonant condition for the temperature range of interest.

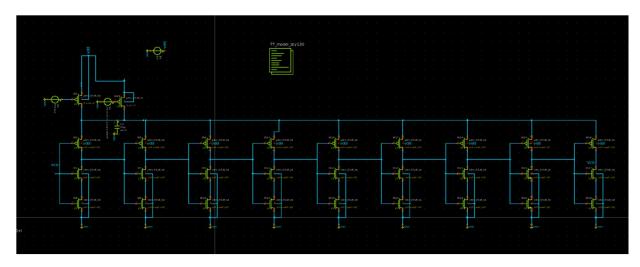


Fig. 4a. Circuit schematic of ring oscillator based VCO

The component details and circuit simulations results are given below:

(A)Component details:

The delay element stages along with the current source is shown in Fig.4b. The device dimension details are given in Table 4

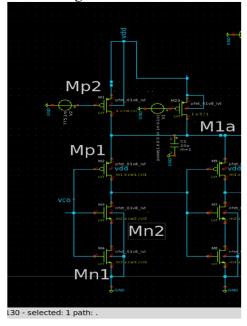


Fig. 4b. Delay element stages

Table 4: Component values of VCO

Devices	W/L
Mn1	1/1
Mn2	7/8
Mp1	0.55/4
Mp2	1/1
M1a	5/1

M1a is the switch used to force the transistor into oscillation state during power up. The switch is turned for a short duration of 100nS. The current that is drawn during this on duration turn out to be 23uA.

(B)Prelayout Simulation results

Oscillation and the range of operating frequencies of VCO was verified in extreme temperature and under process corners. The VCO gain characteristic is shown below. For extreme temperature settings and under nominal process corners, the control voltage was varied in equal increments and the period was measured using "trig" command. Using the period information of VCO output signal, frequencies obtained from VCO are plotted as a function of control voltage

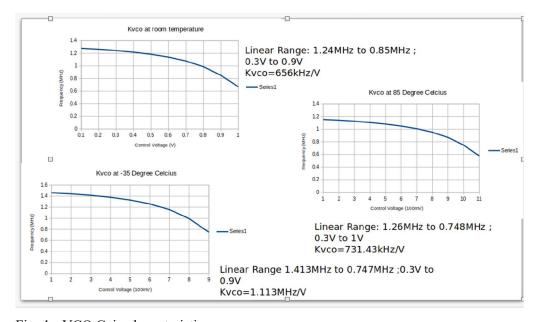


Fig. 4c. VCO Gain characteristics

From the characteristics it can observed that VCO gain characteristics meets the range of frequency variations required by Wein Bridge.

(C) Layout Details:

The cells are placed such that the metals takes shorter route between transistors. A decoupling capacitance of 20pF is used from the source node of current source to ground inorder to filter the supply noise about resonant frequency. PMOS type capacitor is used with 25 fingers and 2 multipliers of W/L equals 7/8 transistors. Presently LVS and postlayout simulations for VCO is under progress.

(5) Divider

The divider is used for obtaining division factor of 4. An inphase and a quadrature phase divide by 4 signal are generated from VCO output signal. The block diagram is shown in Fig. 5a. This is realised by using master slave multiplexer based Flip Flop. Circuit schematic of the master slave flip flop is shown in the below figure Fig. 5b. Clear signal resets the state of the closed loop by breaking open the feedback loop and forcing the value to zero. This is carried out by means of a NOR operation.

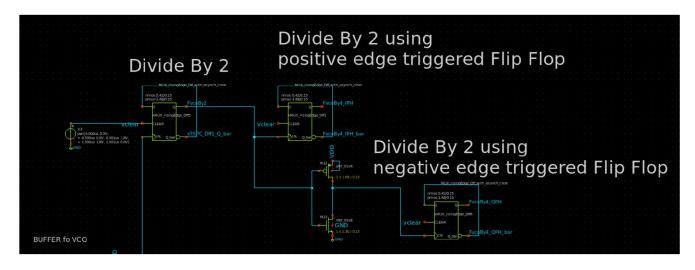


Fig.5a. Block diagram of Mux based static Flip Flop

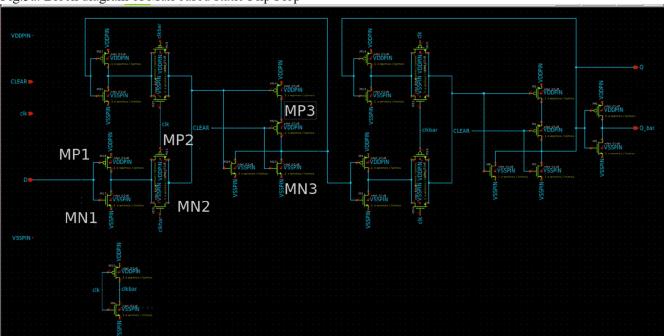


Fig.5. Circuit Schematic diagram of Mux based static Flip Flop

Table 5: Component values of Flip Flop

Devices	W/L
Mn1	1.68/0.15
Mn2	1.68/0.15
Mn3	1.68/0.15
Mp1	0.42/0.15
Mp2	0.42/0.15
Mp3	0.42/0.15

(B) Simulation results

Simulation results will be discussed in closed loop simulation results section.

(C) Pending Task: At extreme temperatures and process corners, postlayout simulations have to be carried out.

6) Edge Combiner

Edge combiner is realized using NAND gates that combines VCO outputs from each of its 9 delay stages. Buffers are used to drive the edge combiner. The circuit schematic is shown in Fig. 6a.

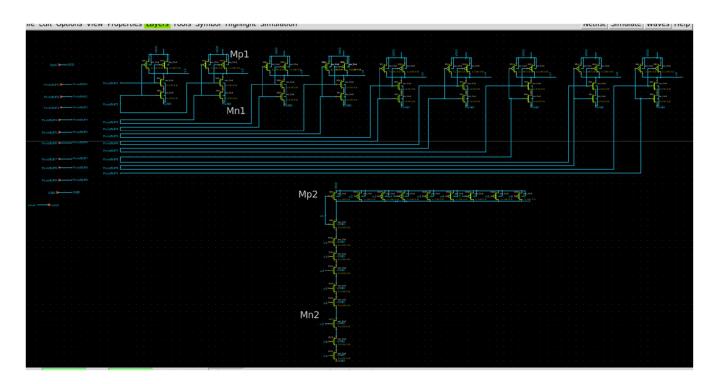


Fig. 6. Circuit schematic of Edge combiner

Component details and circuit simulations are given below

(A) Component Details

The W/Ls of the NAND gate are chosen to have a delay matched with a reference inverter delay. The dimensions are given in the Table.6

Devices	W/L
Mn1	0.74/0.15
Mp1	1.68/0.15
Mn2	3.24/0.15
Mp2	1.68/0.15

(B) Simulation results

Combining the edges from the delay elements a 9 times frequency of VCO signal is generated and the simulation results will be discussed in closed loop simulation results section.

(C) Pending Task: At extreme temperatures and process corners, postlayout simulations have to be carried out.

5) Closed Loop Simulations

Closed loop simulations and functionality verifications are carried out as below

- (a) FLL integrated with edgecombiner at room temperature and at nominal process corners
- (b) FLL integrated with edgecombiner at -35°C and at nominal process corners
- (c) FLL integrated with edgecombiner at +85°C and at nominal process corners
- (d) FLL integrated with edgecombiner at -35°C and at SS corner
- (e) FLL integrated with edgecombiner at +85°C and at FF corner
- (f) FLL integrated with edge combiner at -35 $^{\circ}$ C and at hh corner (to take into account process variation in polysilicon resistors)
- (g)FLL integrated with edgecombiner, 20 bit counter at room temperature and at nominal process corners

Closed loop simulations are carried out using the circuit schematic diagram shown in Fig.7. Results of each of the settings mentioned above are explained below.

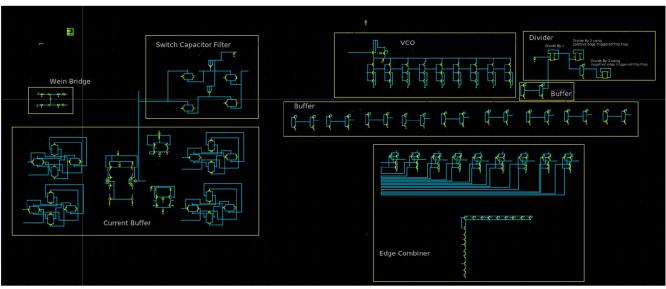


Fig.7a Closed loop Circuit schematic of FLL integrated with Edge combiner

(a)FLL integrated with edgecombiner at room temperature and at nominal process corners

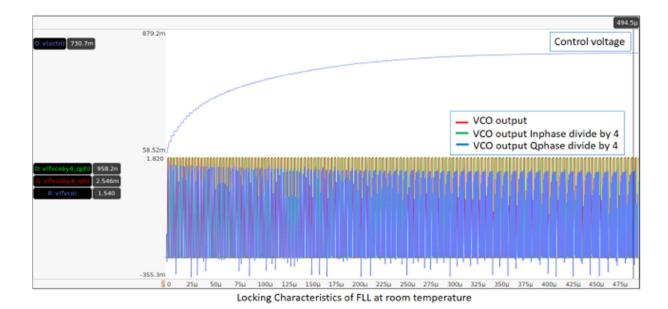


Fig. 7b showing locking characteristics of control voltage, VCO and Divider output The control voltage from Fig.7b. is of 730.7mV at nearly about 2.5 time constants(measured at 500us from the above plot, loop bandwidth of the system is 5kHz). This is then used in the VCO test bench setup at room temperature, period and hence frequency of VCO output is measured. This is shown in Fig.7c.

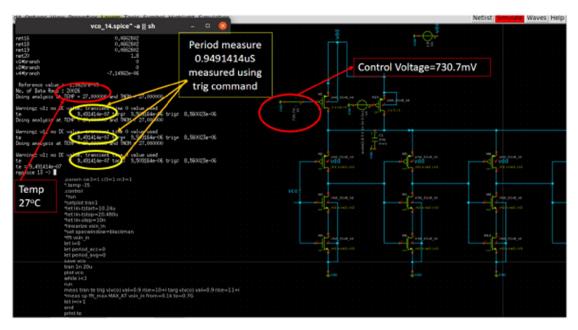


Fig.7c VCO test bench for measuring frequency at room temperature

Using the control voltage setting of 730.7mV, from the corresponding VCO output period is measured using Trig command. This is found to be 0.9491414us and the corresponding frequency is 1.05358379689MHz.

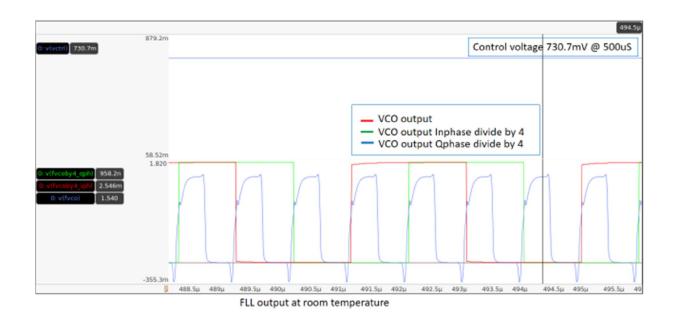


Fig. 7d shows VCO output, Inphase, Quadrature phase divide by 4 Output at room temperature

From the above Fig. 7d., under locked condition divide by 4 nature of inphase, quadrature phase of the divider output signal can be observed.

Similar measurements are made at extreme temperatures at -35°C and at +85°C. The respective plots, test bench setup are shown in the below section (b) and (c).

(b) FLL integrated with edge combiner at -35°C and at nominal process corners

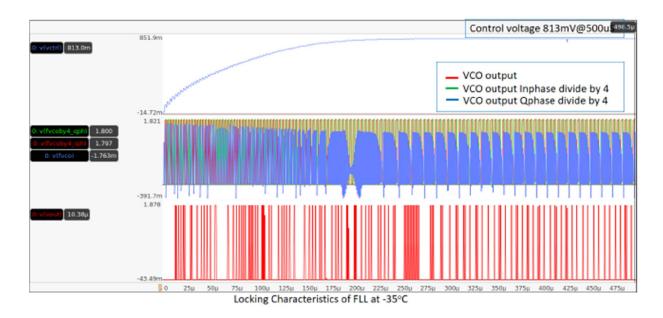


Fig. 7e showing locking characteristics of control voltage, VCO and Divider output at -35°C

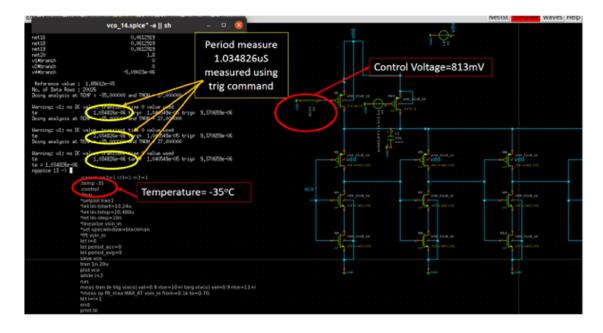


Fig.7f VCO test bench for measuring frequency at -35°C

The control voltage from Fig.7e. the control voltage is observed to be 813 mV at -35°C . This is used in VCO test bench setup at -35°C , period and hence frequency of VCO output is measured. This is shown in Fig.7f. Period is measured to be 1.034826us and the respective frequency measure is 966.34603305kHz.

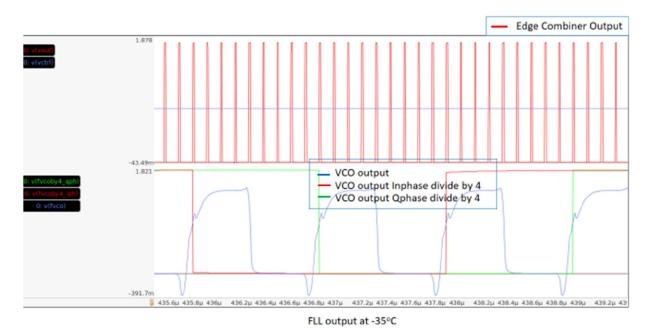
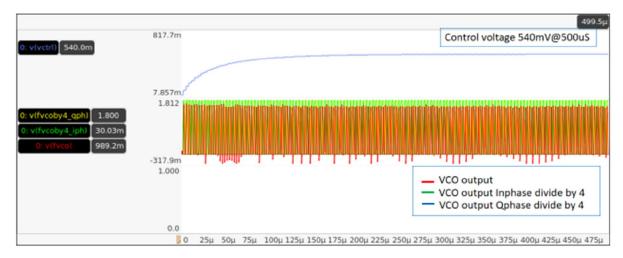


Fig. 7g shows VCO output, Inphase , Quadrature phase divide by 4 Output and Edge combiner output at -35 $^{\circ}\mathrm{C}$

From the above Fig. 7g., under locked condition divide by 4 nature, inphase, quadrature phase of the divider output signal, edge combiner output can be observed. Edge combiner output can be observed to be nine time the frequency of VCO signal (Fvco).

(c) FLL integrated with edgecombiner at +85°C and at nominal process corners



Locking Characteristics of FLL at +85°C

Fig.7h VCO test bench for measuring frequency at 85°C

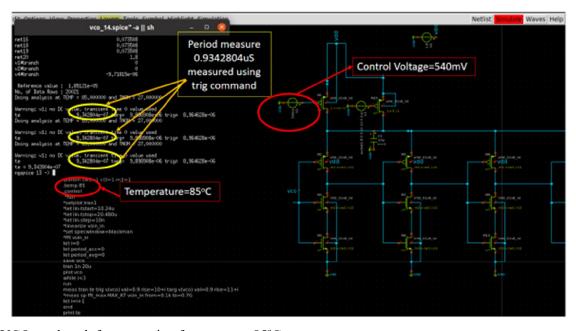


Fig.7i VCO test bench for measuring frequency at 85°C

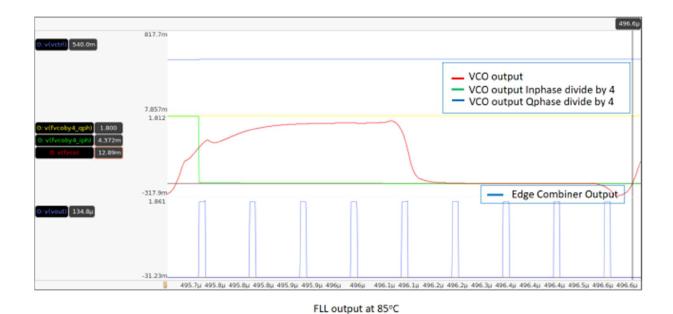


Fig. 7j shows VCO output, Inphase , Quadrature phase divide by 4 Output and Edge combiner output at $85^{\circ}\mathrm{C}$

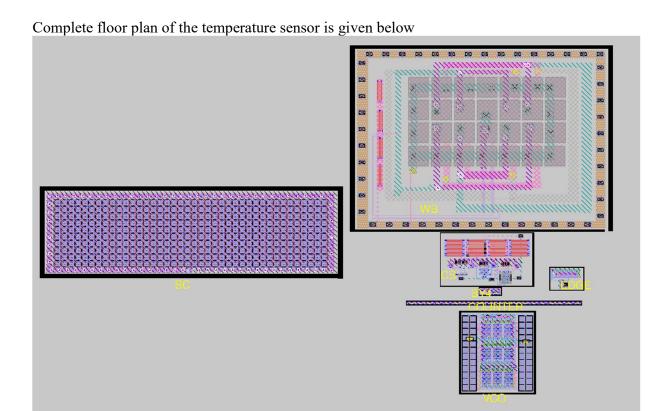
The control voltage from Fig.7h. the control voltage is observed to be $540 \mathrm{mV}$ at $85^{\circ}\mathrm{C}$. This is used in VCO test bench setup at $85^{\circ}\mathrm{C}$, period and hence frequency of VCO output is measured. This is shown in Fig.7f. Period is measured to be $0.9342804 \mathrm{us}$ and the respective frequency measure is $1.034826 \mathrm{MHz}$.

These measurements from simulations show a 104ns difference in the time interval for a temperature range of -35°C to 80°C

Similar measurements for time period of VCO output signal has been carried out under various process corners and at temperature extremes

Process	temperature	Time period
hh	-35°C	1.256651us
SS	-35°C	1.111814us
ff	+85	0.8824711us

A complete integration of the system with 20 bit counter is carried out and transitions in 13th bit was observed



The temperature sensor circuit area was found to be 280um^2

- 6.Summary of the present status
- i. All functional blocks layout is complete
- ii. Postlayout simulation have to be carried out for 20bit counter and divider, rest of the blocks are verified
- iii. Temerature range and mapping to binary code and estimating the accuracy are to completed